	Application No.	Applicant(s)
Notice of Allowability	10/816,947	MCCANDLES ET AL.
	Examiner	Art Unit
	Shih-Chao Chen	2821
The MAILING DATE of this communication apperall daims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	plication. If not included will be mailed in due course. THIS
1. This communication is responsive to the I.D.S. filed on June 25, 2004.		
2. The allowed claim(s) is/are 40-44.		
3. The drawings filed on <u>05 April 2004</u> are accepted by the Examiner.		
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF		
INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
6. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	on's Patent Drawing Review (PTO- s Amendment / Comment or in the C	Office action of ngs in the front (not the back) of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT		
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 6/25/04 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	6. ☐ Interview Summary Paper No./Mail Da 98), 7. ☑ Examiner's Amendr	te ment/Comment ent of Reasons for Allowance Shih-Chao Chen

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DETAILED ACTION

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

On page 11, line 8, "polarization plate 900" is changed to --polarization plate 400-

2. The preliminary amendment filed on April 5, 2004 is acknowledged.

Allowable Subject Matter

- 3. Claims 40-44 are allowed (Claims 1-39 are canceled by Applicant).
- 4. The following is an examiner's statement of reasons for allowance:

The primary reason for the allowance of claims 40-42 is the inclusion of the limitation of the aperture is defined by two side walls parallel with a plane oblique to the first and second polarizations. It is this limitation found in each of the claims, as it is claimed in the combination, that has not been found, taught or suggested by the prior art of record which makes these claims allowable over the prior art.

The primary reason for the allowance of claim 43 is the inclusion of the limitation of the physical configuration of the wave guide includes a continuous unobstructed aperture defined by two side walls parallel with a plane oblique to the two orthogonal polarizations. It is this limitation found in the claim, as it is claimed in the combination,

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that has not been found, taught or suggested by the prior art of record which makes this claim allowable over the prior art.

The primary reason for the allowance of claim 44 is the inclusion of the limitation of the slot continuously extends between the first and second wave guides along a longitudinal axis and is oblique to the two orthogonal polarizations. It is this limitation found in the claim, as it is claimed in the combination, that has not been found, taught or suggested by the prior art of record which makes this claim allowable over the prior art.

Nuding et al. (U.S. Patent No. 4,311,973) teaches a junction for connecting together two waveguides whose major transverse axes are inclined to one another, composed of elements connecting the frontal faces of the waceguides in such a manner that their major axes are adjustably inclined to one another, flanges covering the nonoverlapping frontal faces of the two waveguides. However, Nuding et al. does not disclose or suggest the physical configuration of the wave guide includes a continuous unobstructed aperture defined by two side walls parallel with a plane oblique to the two orthogonal polarizations.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Correspondence

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shih-Chao Chen whose telephone number is (571) 272-

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1819. The examiner can normally be reached on Monday-Friday from 7 AM to 4:30 PM, First Fri. off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Don Wong can be reached on (571) 272-1834. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Shih-Chao Chen Primary Examiner Art Unit 2821

SHIH-CHAO CHEN PRIMARY EXAMINER

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SXC June 8, 2005